PATENT

OCT 02 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Makoto OUCHI

Application No. 10/531,192

Filed: April 13, 2005

For: PANORAMA SYNTHESIS PROCESSING)
OF A PLURALITY OF IMAGE DATA

OF The the application of:

(Aroup Art Unit: 2621

Examiner: Not Assigned

Atty. Docket No. MIPFP160

Date: September 29, 2006

Confirmation No. 6287

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on September 29, 2006.

igned:

Diane Schwanbeck

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents Post Office Box 1450 Alexandria, VA 22313-1450

Dear Sir:

The references listed in the attached PTO Form 1449, copies of the non-U.S. references of which are attached, may be material to examination of the above-identified patent application. Applicant submits these references in compliance with his duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97. The Examiner is requested to consider these references and to acknowledge such consideration by initialing the attached PTO Form 1449 at the appropriate locations.

Applicant states that the references listed in the attached PTO Form 1449 were cited in a counterpart European application not more than three months prior to the filing of this Information Disclosure Statement (IDS) (for the Examiner's use and information, copies of the Supplementary European Search Report and the Communication from the EPO showing that the search report was mailed on June 30, 2006 are attached). Accordingly, no fees are due in connection with the filing of this IDS. In the event fees are due to effect consideration of the cited references, the Commissioner may charge such fees to Deposit Account 50-0805 (Order No. MIPFP160).

Respectfully submitted,

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Substitute for form 1449/PTO					Application Number	10/531,192
/	Š\				Filing Date:	April 13, 2005
0	Information Disclosure Statement By Applicant (Use as many sheets as necessary)				First Named Inventor:	Makoto OUCHI
12/2					Art Unit:	2621
1665					Examiner Name:	
		<u> </u>			Attorney Docket Number:	MIPFP160
	Sheet	1	of	1		

U.S. Patent Documents

Cion atom Doddinonto					
Examiner Initial	Cite No.	Document No.	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, where Relevant Passages or Relevant Figures Appear
	Α	5,987,164	11/1999	Szeliski et al.	
	В	6,486,908	11/2002	Chen et al.	
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Foreign Patent Documents

Examiner Initial	Cite No.	Foreign Patent Document No.	Publication Date	Name of Patentee or Applicant of Cited	Pages, Columns, Lines, where	Translation	
				Document	Relevant Passages or Relevant Figures Appear	YES	NO
	L						
	М						
	N						
	0						
	Р						
	Q						

Non Patent Literature Documents

Examiner	Cite	Include name of author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book,
Initial	No.	magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	R	R. Szeliski and HY. Shum, "Creating Full View Panoramic Image Mosaics and
		Environment Maps," Computer Graphics Proceedings, Proceedings of SIGGRAPH
		Annual International Conference on Computer Graphics and Interactive Techniques
		(1997), pp. 251-258, XP002378648
	S	M. Traka and G. Tziritas, "Panoramic View Construction," Signal Processing: Image
		Communication, Vol. 18, No. 6 (July 2003), pp. 465-481, XP004427613
	Т	DH. Kim et al., "An Efficient Method to Build Panoramic Image Mosaics," Pattern
		Recognition Letters, Vol. 24, No. 14 (Oct. 2003), pp. 2421-2429, XP004437193
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	W	

Examiner Signature	Date Considered
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Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.